Shizuo Fujita

List of Publications by Year in Descending Order

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The third column is the impact factor (IF) of the journal, and the fourth column is the number of citations of the article.

137
papers

5,301
citations

142
ext. papers

5,875
ext. citations

36
h-index
g-index

5,875
avg, IF

L-index

#	Paper	IF	Citations
137	Novel p-type oxides with corundum structure for gallium oxide electronics. <i>Journal of Materials Research</i> , 2022 , 37, 651-659	2.5	2
136	Prospects for phase engineering of semi-stable Ga2O3 semiconductor thin films using mist chemical vapor deposition. <i>Journal of Applied Physics</i> , 2022 , 131, 090902	2.5	8
135	Research of Semiconductor Materials That Emit in the Vacuum Ultraviolet Region of 200 nm or Less. <i>Zairyo/Journal of the Society of Materials Science, Japan</i> , 2021 , 70, 727-731	0.1	
134	Ultra-wide bandgap corundum-structured p-type ﴿Ir,Ga)2O3 alloys for Æa2O3 electronics. Applied Physics Letters, 2021 , 118, 102104	3.4	14
133	Analysis of Deep Traps in Mist Chemical Vapor Deposition-Grown n-Type EGa2O3 by Photocapacitance Method. <i>Physica Status Solidi (B): Basic Research</i> , 2021 , 258, 2000622	1.3	3
132	Thermal stability of E(Al x Ga1☑)2O3 films grown on c-plane sapphire substrates with an Al composition up to 90%. <i>Japanese Journal of Applied Physics</i> , 2021 , 60, SBBD13	1.4	6
131	Identification of free and bound exciton emission of MgO single crystal in vacuum ultraviolet spectral range. <i>Applied Physics Letters</i> , 2021 , 119, 132105	3.4	1
130	Impact of hydrochloric acid on the epitaxial growth of In2O3 films on (0001)#Al2O3 substrates by mist CVD. <i>Applied Physics Express</i> , 2020 , 13, 075504	2.4	3
129	Thermal stability of EGa2O3 films grown on c-plane sapphire substrates via mist-CVD. <i>AIP Advances</i> , 2020 , 10, 115013	1.5	8
128	Pure deep-ultraviolet cathodoluminescence from rocksalt-structured MgZnO grown with carbon-free precursors. <i>Applied Physics Express</i> , 2019 , 12, 052011	2.4	10
127	Enhancement of epitaxial lateral overgrowth in the mist chemical vapor deposition of HGa2O3 by using a-plane sapphire substrate. <i>Japanese Journal of Applied Physics</i> , 2019 , 58, 120912	1.4	16
126	A power device material of corundum-structured EGa2O3fabricated by MIST EPITAXYII technique. Japanese Journal of Applied Physics, 2018 , 57, 02CB18	1.4	50
125	Electrical characterization of Si-doped n-type EGa2O3 on sapphire substrates. <i>MRS Advances</i> , 2018 , 3, 171-177	0.7	24
124	Control of Crystal Structure of Ga2O3 on Sapphire Substrate by Introduction of E(AlxGa1☑)2O3 Buffer Layer. <i>Physica Status Solidi (B): Basic Research</i> , 2018 , 255, 1700326	1.3	27
123	Evaluation of band alignment of EGa2O3/E(AlxGa1E)2O3heterostructures by X-ray photoelectron spectroscopy. <i>Japanese Journal of Applied Physics</i> , 2018 , 57, 040314	1.4	29
122	Deep-Ultraviolet Luminescence of Rocksalt-Structured MgxZn1⊠O (x > 0.5) Films on MgO Substrates. <i>Journal of Electronic Materials</i> , 2018 , 47, 4356-4360	1.9	10
121	Electrical properties of <code>ar2O3/</code> a2O3 pn heterojunction diode and band alignment of the heterostructure. <i>Applied Physics Letters</i> , 2018 , 113, 212104	3.4	49

(2015-2018)

120	Tin oxide coating by nonvacuum-based mist chemical vapor deposition on stainless steel separators for polymer electrolyte fuel cells. <i>Japanese Journal of Applied Physics</i> , 2018 , 57, 117103	1.4	20
119	Corundum-Structured ⊞n2O3 as a Wide-Bandgap Semiconductor for Electrical Devices. <i>MRS Advances</i> , 2017 , 2, 301-307	0.7	5
118	Corundum-strructured EGa2O3-based alloys for future power device applications 2017 ,		1
117	Conductivity control of Sn-doped EGa2O3thin films grown on sapphire substrates. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202BA	1.4	63
116	Growth of rocksalt-structured MgxZn1⊠O (x> 0.5) films on MgO substrates and their deep-ultraviolet luminescence. <i>Applied Physics Express</i> , 2016 , 9, 111102	2.4	15
115	Reduction in edge dislocation density in corundum-structured EGa2O3layers on sapphire substrates with quasi-graded E(Al,Ga)2O3buffer layers. <i>Applied Physics Express</i> , 2016 , 9, 071101	2.4	49
114	Growth characteristics of corundum-structured <code>E(Al Ga1)</code> 2O3/Ga2O3 heterostructures on sapphire substrates. <i>Journal of Crystal Growth</i> , 2016 , 436, 150-154	1.6	50
113	Crystal Growth and Device Applications of Corundum-Structured Gallium Oxide. <i>Zairyo/Journal of the Society of Materials Science, Japan</i> , 2016 , 65, 631-637	0.1	
112	Silver oxide Schottky contacts and metal semiconductor field-effect transistors on SnO2thin films. <i>Applied Physics Express</i> , 2016 , 9, 041101	2.4	21
111	Characterization of band offset in E(AlxGa1-x)2O3/EGa2O3 heterostructures 2016 ,		1
111	Characterization of band offset in E(AlxGa1-x)2O3/EGa2O3 heterostructures 2016, Surface termination structure of EGa2O3 film grown by mist chemical vapor deposition. Applied Physics Letters, 2016, 108, 251602	3.4	20
	Surface termination structure of HGa2O3 film grown by mist chemical vapor deposition. <i>Applied</i>	3.4	
110	Surface termination structure of £Ga2O3 film grown by mist chemical vapor deposition. <i>Applied Physics Letters</i> , 2016 , 108, 251602 Evolution of corundum-structured III-oxide semiconductors: Growth, properties, and devices.		20
110	Surface termination structure of £Ga2O3 film grown by mist chemical vapor deposition. <i>Applied Physics Letters</i> , 2016 , 108, 251602 Evolution of corundum-structured III-oxide semiconductors: Growth, properties, and devices. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202A3 Homoepitaxial growth of beta gallium oxide films by mist chemical vapor deposition. <i>Japanese</i>	1.4	20
110 109 108	Surface termination structure of EGa2O3 film grown by mist chemical vapor deposition. <i>Applied Physics Letters</i> , 2016 , 108, 251602 Evolution of corundum-structured III-oxide semiconductors: Growth, properties, and devices. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202A3 Homoepitaxial growth of beta gallium oxide films by mist chemical vapor deposition. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202B8 Transparent conductive zinc-oxide-based films grown at low temperature by mist chemical vapor	1.4	20 81 51
110 109 108	Surface termination structure of EGa2O3 film grown by mist chemical vapor deposition. <i>Applied Physics Letters</i> , 2016 , 108, 251602 Evolution of corundum-structured III-oxide semiconductors: Growth, properties, and devices. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202A3 Homoepitaxial growth of beta gallium oxide films by mist chemical vapor deposition. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202B8 Transparent conductive zinc-oxide-based films grown at low temperature by mist chemical vapor deposition. <i>Thin Solid Films</i> , 2015 , 597, 30-38	1.4	20815137
110 109 108 107	Surface termination structure of EGa2O3 film grown by mist chemical vapor deposition. <i>Applied Physics Letters</i> , 2016 , 108, 251602 Evolution of corundum-structured III-oxide semiconductors: Growth, properties, and devices. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202A3 Homoepitaxial growth of beta gallium oxide films by mist chemical vapor deposition. <i>Japanese Journal of Applied Physics</i> , 2016 , 55, 1202B8 Transparent conductive zinc-oxide-based films grown at low temperature by mist chemical vapor deposition. <i>Thin Solid Films</i> , 2015 , 597, 30-38 Vertical Schottky barrier diodes of EGa2O3 fabricated by mist epitaxy 2015 , Growth and metal®xide®emiconductor field-effect transistors of corundum-structured alpha	1.4	208151373

102	Mist chemical vapor deposition of aluminum oxide thin films for rear surface passivation of crystalline silicon solar cells. <i>Applied Physics Express</i> , 2014 , 7, 021303	2.4	15
101	Ultrasonic-assisted mist chemical vapor deposition of II-oxide and related oxide compounds. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2014 , 11, 1225-1228		19
100	Growth of corundum-structured (InxGa1日)2O3 alloy thin films on sapphire substrates with buffer layers. <i>Journal of Crystal Growth</i> , 2014 , 401, 670-672	1.6	30
99	Aluminum Oxide Passivation Layer for Crystalline Silicon Solar Cells Deposited by Mist CVD in Open-Air Atmosphere. <i>Materials Research Society Symposia Proceedings</i> , 2014 , 1647, 1		
98	Epitaxial growth of corundum-structured wide band gap III-oxide semiconductor thin films. <i>Journal of Crystal Growth</i> , 2014 , 401, 588-592	1.6	102
97	Band gap and function engineering for novel functional alloy semiconductors: Bloomed as magnetic properties at room temperature with (GaFe) 203. <i>Journal of Applied Physics</i> , 2013 , 113, 23390	o 2 .5	53
96	Growth of corundum-structured In2O3 thin films on sapphire substrates with Fe2O3 buffer layers. Journal of Crystal Growth, 2013 , 364, 30-33	1.6	55
95	Formation of Semi-Insulating Layers on Semiconducting EGa2O3Single Crystals by Thermal Oxidation. <i>Japanese Journal of Applied Physics</i> , 2013 , 52, 051101	1.4	25
94	Thermal stability of single crystalline alpha gallium oxide films on sapphire substrates. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2013 , 10, 1592-1595		47
93	Fabrication of Corundum-Structured E(InFe)2O3 Alloy Films on Sapphire Substrates by Inserting Fe2O3 Buffer Layer. <i>Materials Research Society Symposia Proceedings</i> , 2013 , 1494, 221-225		1
92	Crystal Structure of Non-Doped and Sn-Doped E(GaFe)2O3 Thin Films <i>Materials Research Society Symposia Proceedings</i> , 2013 , 1494, 147-152		3
91	Oriented growth of beta gallium oxide thin films on yttrium-stabilized zirconia substrates. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2013 , 10, 1596-1599		17
90	Formation of aluminum tris (8-hydroxyquinoline) solution in methanol and fabrication of thin films by ultrasonic spray-assisted vapor deposition. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2012 , 209, 1298-1301	1.6	8
89	Thin Film Formation of Transparent Conductive Oxides by Solution-Based Mist Deposition Method toward Hybrid Device Applications. <i>Materials Research Society Symposia Proceedings</i> , 2012 , 1400, 1		2
88	Fabrication of Organic Polymer Solar Cells by a Novel Solution-Based Vapor-like Mist Deposition Method. <i>Materials Research Society Symposia Proceedings</i> , 2012 , 1390, 47		2
87	Fabrication of Organic Small Molecular Thin Films based on Ultrasonic Spray-Assisted Vapor-Deposition Method. <i>Materials Research Society Symposia Proceedings</i> , 2012 , 1400, 29		
86	Growth and Band Gap Control of Corundum-Structured \$alpha\$-(AlGa)\$_{2}\$O\$_{3}\$ Thin Films on Sapphire by Spray-Assisted Mist Chemical Vapor Deposition. <i>Japanese Journal of Applied Physics</i> , 2012 , 51, 100207	1.4	30
85	Evaluation of Misfit Relaxation in EGa2O3Epitaxial Growth on EAl2O3Substrate. <i>Japanese Journal of Applied Physics</i> , 2012 , 51, 020201	1.4	15

(2009-2012)

84	Electrical Conductive Corundum-Structured Ca2O3Thin Films on Sapphire with Tin-Doping Grown by Spray-Assisted Mist Chemical Vapor Deposition. <i>Japanese Journal of Applied Physics</i> , 2012 , 51, 0702	03 ^{1.4}	15	
83	Fundamental Properties and Optical Device Applications of ZnO. <i>The Review of Laser Engineering</i> , 2011 , 39, 165-170	О		
82	Extraction of Trap Densities in ZnO Thin-Film Transistors and Dependence on Oxygen Partial Pressure During Sputtering of ZnO Films. <i>IEEE Transactions on Electron Devices</i> , 2011 , 58, 3018-3024	2.9	20	
81	Fabrication of PEDOT:PSS/ZnMgO Schottky-type ultraviolet sensors on glass substrates with solution-based mist deposition technique and hard-mask patterning. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2011 , 8, 613-615		21	
80	Growth of SnO2 crystalline thin films by mist chemical vapour deposition method. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2011 , 8, 540-542		35	
79	Reduction of Photo-Leakage Current in ZnO Thin-Film Transistors With Dual-Gate Structure. <i>IEEE Electron Device Letters</i> , 2011 , 32, 509-511	4.4	6	
78	Effects of chemical stoichiometry of channel region on bias instability in ZnO thin-film transistors. <i>Applied Physics Letters</i> , 2011 , 98, 103512	3.4	12	
77	Ultrasonic Spray-Assisted Solution-Based Vapor-Deposition of Aluminum Tris(8-hydroxyquinoline) Thin Films. <i>Japanese Journal of Applied Physics</i> , 2011 , 50, 020204	1.4	4	
76	Artificial Surface Control of Gallium Oxide Semiconductors and Growth of High Quality Single-crystalline Thin Films. <i>Hyomen Kagaku</i> , 2010 , 31, 643-650			
75	Mechanism analysis of photoleakage current in ZnO thin-film transistors using device simulation. <i>Applied Physics Letters</i> , 2010 , 97, 163503	3.4	12	
74	Analysis of Hump Characteristics in Thin-Film Transistors With ZnO Channels Deposited by Sputtering at Various Oxygen Partial Pressures. <i>IEEE Electron Device Letters</i> , 2010 ,	4.4	25	
73	69.1: Photo-Leakage Current in ZnO TFTs for Transparent Electronics. <i>Digest of Technical Papers SID International Symposium</i> , 2010 , 41, 1029	0.5	4	
72	Growth characteristics of single-crystalline ZnMgO layers by ultrasonic spray assisted mist CVD technique. <i>Physica Status Solidi (B): Basic Research</i> , 2010 , 247, 1460-1463	1.3	28	
71	Corundum-structured phase Ga2O3-Cr2O3-Fe2O3 alloy system for novel functions. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2010 , 7, 2467-2470		27	
70	Flame Detection by a EGa2O3-Based Sensor. <i>Japanese Journal of Applied Physics</i> , 2009 , 48, 011605	1.4	111	
69	EAl2xGa2-2xO3Thin Film Growth by Molecular Beam Epitaxy. <i>Japanese Journal of Applied Physics</i> , 2009 , 48, 070202	1.4	91	
68	Epitaxial ZnO Thin Films ona-Plane Sapphire Substrates Grown by Ultrasonic Spray-Assisted Mist Chemical Vapor Deposition. <i>Japanese Journal of Applied Physics</i> , 2009 , 48, 121103	1.4	41	
67	Fabrication of Highly Crystalline Corundum-Structured E(Ga1-xFex)2O3Alloy Thin Films on Sapphire Substrates. <i>Applied Physics Express</i> , 2009 , 2, 075501	2.4	69	

66	Mist deposition technique as a green chemical route for synthesizing oxide and organic thin films. <i>Materials Research Society Symposia Proceedings</i> , 2009 , 1220, 4061		3
65	Heteroepitaxy of Corundum-Structured EGa2O3Thin Films on EAl2O3Substrates by Ultrasonic Mist Chemical Vapor Deposition. <i>Japanese Journal of Applied Physics</i> , 2008 , 47, 7311-7313	1.4	295
64	Growth of Crystalline Zinc Oxide Thin Films by Fine-Channel-Mist Chemical Vapor Deposition. <i>Japanese Journal of Applied Physics</i> , 2008 , 47, 4669-4675	1.4	89
63	Vertical Solar-Blind Deep-Ultraviolet Schottky Photodetectors Based on EGa2O3Substrates. <i>Applied Physics Express</i> , 2008 , 1, 011202	2.4	270
62	Ultrasonic spray assisted Mist-CVD method for high-quality crystalline and amorphous oxide semiconductors growth. <i>Materials Research Society Symposia Proceedings</i> , 2008 , 1113, 1		
61	Properties of Ga2O3-based (Inx Ga1☑)2O3 alloy thin films grown by molecular beam epitaxy. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2008 , 5, 3113-3115		60
60	An approach for single crystalline zinc oxide thin films with fine channel mist chemical vapor deposition method. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2008 , 5, 3138-3140		27
59	Step-flow growth of homoepitaxial ZnO thin films by ultrasonic spray-assisted MOVPE. <i>Journal of Crystal Growth</i> , 2008 , 310, 5007-5010	1.6	22
58	Surface morphology of homoepitaxial EGa2O3 thin films grown by molecular beam epitaxy. <i>Thin Solid Films</i> , 2008 , 516, 5768-5771	2.2	112
57	Ga2O3Thin Film Growth onc-Plane Sapphire Substrates by Molecular Beam Epitaxy for Deep-Ultraviolet Photodetectors. <i>Japanese Journal of Applied Physics</i> , 2007 , 46, 7217-7220	1.4	399
56	Low-Temperature Growth of ZnO Thin Films by Linear Source Ultrasonic Spray Chemical Vapor Deposition. <i>Japanese Journal of Applied Physics</i> , 2007 , 46, 6811-6813	1.4	60
55	Direct Fabrication of ZnO Whiskers Bridging Between Micron-gap Electrodes in Aqueous Solution for Highly Gas Sensing. <i>Materials Research Society Symposia Proceedings</i> , 2007 , 1035, 1		
54	Linear-Source Ultrasonic Spray Chemical Vapor Deposition Method for Fabrication of ZnMgO Films and Ultraviolet Photodetectors. <i>Japanese Journal of Applied Physics</i> , 2006 , 45, L857-L859	1.4	77
53	Fabrication and Properties of ZnO Thin Films Prepared by Fine Channel Mist Mehtod. <i>Zairyo/Journal of the Society of Materials Science, Japan</i> , 2006 , 55, 153-158	0.1	27
52	Fabrication of wide-band-gap MgxZn1⊠O quasi-ternary alloys by molecular-beam epitaxy. <i>Applied Physics Letters</i> , 2005 , 86, 192911	3.4	85
51	Molecular Beam Epitaxy of High Magnesium Content Single-Phase Wurzite MgxZn1-xO Alloys (\$xsimeq 0.5\$) and Their Application to Solar-Blind Region Photodetectors. <i>Japanese Journal of Applied Physics</i> , 2003 , 42, L401-L403	1.4	152
50	Selective formation of ZnO nanodots on nanopatterned substrates by metalorganic chemical vapor deposition. <i>Applied Physics Letters</i> , 2003 , 83, 3593-3595	3.4	35
49	Self-organized ZnO quantum dots on SiO2/Si substrates by metalorganic chemical vapor deposition. <i>Applied Physics Letters</i> , 2002 , 81, 5036-5038	3.4	135

48	Hexagonal GaN grown on GaAs{11n} substrates by metalorganic vapor-phase epitaxy using AlAs intermediate layers. <i>Applied Physics Letters</i> , 2001 , 79, 4133-4135	3.4	6
47	Vacuum Deposition and Luminescence Dynamics of Organic Thin Film Multi-Structures. Shinku/Journal of the Vacuum Society of Japan, 2001 , 44, 948-955		
46	Single-phase hexagonal GaN grown on AlAs/GaAs(001). Applied Physics Letters, 2000, 77, 244-246	3.4	7
45	Six-bilayer periodic structures in GaN grown on GaAs(001). <i>Applied Physics Letters</i> , 2000 , 76, 330-332	3.4	3
44	Integration of GaN with Si using a AuGe-mediated wafer bonding technique. <i>Applied Physics Letters</i> , 2000 , 77, 3959-3961	3.4	14
43	Electrical Characterization of MOVPE-Grown P-Type GaN:Mg Against Annealing Temperature. <i>MRS Internet Journal of Nitride Semiconductor Research</i> , 1999 , 4, 665-670		1
42	Tunable band offsets via control of interface atomic configuration in GaAs-on-ZnSe(001) heterovalent heterostructures. <i>Journal of Applied Physics</i> , 1999 , 85, 1514-1519	2.5	5
41	Relation between GaAs surface morphology and incorporation of hexagonal GaN into cubic GaN. <i>Journal of Crystal Growth</i> , 1999 , 196, 41-46	1.6	18
40	Luminescence Dynamics of Alq3-Based Multilayer Structures in Terms of HOMO and LUMO Energy Discontinuity. <i>Materials Research Society Symposia Proceedings</i> , 1999 , 598, 321		
39	Growth of p-type Zn(S)Se layers by MOVPE. Journal of Crystal Growth, 1998, 184-185, 398-405	1.6	10
38	A comparative study on deep levels in p-ZnSe grown by MBE, MOMBE and MOVPE. <i>Journal of Crystal Growth</i> , 1998 , 184-185, 495-499	1.6	2
37	The mechanism of radiative recombination in light-emitting devices composed on InGaN quantum wells. <i>Electronics and Communications in Japan</i> , 1998 , 81, 45-56		2
36	Nucleation processes during metalorganic vapor phase epitaxy of ZnSe on GaAs(001). <i>Journal of Applied Physics</i> , 1998 , 84, 1383-1388	2.5	2
35	Deep states in nitrogen-doped p-ZnSe. <i>Journal of Applied Physics</i> , 1998 , 83, 2563-2567	2.5	5
34	Optical Absorption in ZnSe-GaAs Heterovalent Quantum Structures. <i>Materials Research Society Symposia Proceedings</i> , 1998 , 535, 71		
33	Electrical Characterization of Movpe-Grown p-Type GaN:Mg Against Annealing Temperature. <i>Materials Research Society Symposia Proceedings</i> , 1998 , 537, 1		2
32	Stimulated emission from optically pumped GaN quantum dots. <i>Applied Physics Letters</i> , 1997 , 71, 1299	-1 <u>3.Q</u> 1	74
31	Tunable band offsets in ZnSe/GaAs heterovalent heterostructures grown by metalorganic vapor phase epitaxy. <i>Journal of Applied Physics</i> , 1997 , 82, 2984-2989	2.5	13

30	Self-organized CdSe quantum dots onto cleaved GaAs (110) originating from Stranski K rastanow growth mode. <i>Applied Physics Letters</i> , 1997 , 70, 3278-3280	3.4	54
29	Role of self-formed InGaN quantum dots for exciton localization in the purple laser diode emitting at 420 nm. <i>Applied Physics Letters</i> , 1997 , 70, 981-983	3.4	835
28	Effect of cleaving environment on the growth of ZnSe on the GaAs (1 1 0) surface by molecular beam epitaxy. <i>Journal of Materials Science Letters</i> , 1997 , 16, 1187-1190		
27	Effect of cleaving environment on the growth of ZnSe on the GaAs (110) surface by molecular beam epitaxy. <i>Journal of Materials Science Letters</i> , 1997 , 16, 1187-1190		
26	Molecular Beam Epitaxial Growth Behaviors of Zn1-xCdxSe on the GaAs(110) Surface Cleaved in Ultra High Vacuum <i>Shinku/Journal of the Vacuum Society of Japan</i> , 1997 , 40, 317-320		
25	Defect States in p-ZnSe:N Grown by MOVPE. <i>Materials Research Society Symposia Proceedings</i> , 1996 , 442, 561		
24	Surface Reconstruction and Morphology of Hydrogen Sulfide Treated GaAs (001) Substrate. <i>Materials Research Society Symposia Proceedings</i> , 1996 , 448, 15		
23	Emission Mechanism of the InGaN MQW Grown by MOCVD. <i>Materials Research Society Symposia Proceedings</i> , 1996 , 449, 665		
22	Effects of GaAs buffer layer and lattice-matching on deep levels in Zn(S)Se/GaAs heterostructures. <i>Journal of Electronic Materials</i> , 1996 , 25, 217-222	1.9	5
21	Growth of P-type Znse by metalorganic molecular beam epitaxy using metal Zn and dimethylselenide. <i>Journal of Electronic Materials</i> , 1996 , 25, 223-227	1.9	4
20	Effects of annealing atmosphere and temperature on acceptor activation in ZnSe:N grown by photoassisted MOVPE. <i>Journal of Crystal Growth</i> , 1996 , 159, 312-316	1.6	46
19	MO(GS)MBE and photo-MO(GS)MBE of IIIVI semiconductors. <i>Journal of Crystal Growth</i> , 1996 , 164, 196-2	201.6	10
18	Photoassisted growth of IIIVI semiconductor films. <i>Applied Surface Science</i> , 1995 , 86, 431-436	6.7	11
17	Growth of ZnSe/ZnMgSSe quantum well structures by metalorganic molecular beam epitaxy under in situ observation of reflection high energy electron diffraction intensity oscillation. <i>Journal of Crystal Growth</i> , 1995 , 150, 738-742	1.6	3
16	Thermal annealing effects on p-type conductivity of nitrogendoped ZnSe grown by metalorganic vapor phase epitaxy. <i>Journal of Electronic Materials</i> , 1995 , 24, 137-141	1.9	15
15	Gas-Source Molecular Beam Epitaxial Growth of (Zn, Mg)(S, Se) Using Bis-methylcyclopentadienyl-magnesium and Hydrogen Sulfide. <i>Japanese Journal of Applied Physics</i> , 1994 , 33, L290-L293	1.4	16
14	Photocatalytic surface reactions in metalorganic vapor-phase epitaxy. <i>Applied Surface Science</i> , 1994 , 79-80, 41-46	6.7	7
13	Photo-assisted metalorganic vapor-phase epitaxy for nitrogen doping and fabrication of blue-green light emitting devices of ZnSe-based semiconductors. <i>Journal of Crystal Growth</i> , 1994 , 138, 737-744	1.6	15

LIST OF PUBLICATIONS

12	, 1994 , 145, 552-556	1.6	15	
11	Metalorganic vapor phase epitaxy growth and nitrogen-doping of ZnxCd1-xS using photo-assistance. <i>Journal of Crystal Growth</i> , 1994 , 145, 570-575	1.6	5	
10	Photoassisted Metalorganic Vapor-Phase Epitaxy of Nitrogen-Doped ZnSe Using Tertiarybutylamine as Doping Source. <i>Japanese Journal of Applied Physics</i> , 1993 , 32, L1153-L1156	1.4	21	
9	Fabrication of IIIVI semiconductor quantum well structures in ZnCdSSe alloy systems. <i>Physica B: Condensed Matter</i> , 1993 , 191, 57-70	2.8	9	
8	Optically Pumped Blue-Green Laser Operation Above Room-Temperature in Zn0.80Cd0.20Se-ZnS0.08Se0.92Multiple Quantum Well Structures Grown by Metalorganic Molecular Beam Epitaxy. <i>Japanese Journal of Applied Physics</i> , 1991 , 30, L605-L607	1.4	43	
7	A Defect Model for Photoirradiated Semiconductors Buppression of the Self-Compensation in II-VI Materials [] <i>Japanese Journal of Applied Physics</i> , 1991 , 30, 3475-3481	1.4	31	
6	Organometallic vapor-phase epitaxial growth of cubic ZnCdS lattice-matched to GaAs substrate. <i>Journal of Crystal Growth</i> , 1990 , 99, 437-440	1.6	22	
5	Metalorganic Molecular Beam Epitaxial Growth of ZnSe and ZnS on GaAs Substrates Pretreated with (NH4)2SxSolution. <i>Japanese Journal of Applied Physics</i> , 1990 , 29, L144-L147	1.4	50	
4	Rheed and x-ray characterization of InGaAs/GaAs grown by MBE. <i>Journal of Crystal Growth</i> , 1989 , 95, 224-227	1.6	36	
3	Growth Rate Enhancement by Xenon Lamp Irradiation in Organometallic Vapor-Phase Epitaxy of ZnSe. <i>Japanese Journal of Applied Physics</i> , 1987 , 26, L2000-L2002	1.4	67	
2	Mist Chemical Vapor Deposition Growth of ⊞n2O3 Films Using Indium Oxide Powder as Source Precursor. <i>Physica Status Solidi (B): Basic Research</i> ,2100414	1.3	O	
1	Vacuum Ultraviolet Emission Properties of Rocksalt-Structured MgZnO Microcrystals Prepared on Quartz Glass Substrates. <i>Physica Status Solidi (B): Basic Research</i> ,2100354	1.3		